

OLIFF & BERRIDGE, PLC
 P.O. Box 19928
 Alexandria, Virginia 22320
 Telephone: (703) 836-6400
 Facsimile: (703) 836-2787



PATENT APPLICATION

Attorney Docket No.: 110735

AMENDMENT TRANSMITTAL

In re the Application of

Akifumi KAMIJIMA et al.

Application No.: 09/966,080

Filed: October 1, 2001

For: A METHOD FOR FABRICATING A RESIST PATTERN, A METHOD FOR PATTERNING A THIN FILM AND A METHOD FOR MANUFACTURING A MICRO DEVICE

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

Entitlement to small entity status is hereby asserted.
 Small entity status of this application has been established.

The filing fee has been calculated as shown below:

	(Column 1)	(Column 2)	(Column 3)	SMALL ENTITY	OTHER THAN A SMALL ENTITY
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADD'L FEE
TOTAL CLAIMS	46 MINUS	46	= 0	x 9	\$
INDEP CLAIMS	11 MINUS	10	= 1	x 43	\$
<input type="checkbox"/> FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				+ 145	\$
					\$ 86

* If the entry in Column 1 is less than the entry in Column 2, write "0" in Column 3.
 ** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
 *** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.
 The "Highest Number Previously Paid For" in this space (Total or Independent) is the highest number found from the equivalent box in Column 1 of a prior Amendment or the number of claims originally filed.
 Check No. 149247 in the amount of \$86 is attached. The Commissioner is hereby authorized to charge any other fees that may be required to complete this filing, or to credit any overpayment, to Deposit Account No. 15-0461. Two duplicate copies of this sheet are attached.

Respectfully submitted,

James A. Olioff
 Registration No. 27,075

John W. Fitzpatrick
 Registration No. 41,018

JAO:JWF/ldg

Date: December 15, 2003

Group Art Unit: 1756
RECEIVED
 Examiner: J. Ruggles
DEC 18 2003

TC 1700



RECEIVED
DEC 18 2003
TC 1700

PATENT APPLICATION

RESPONSE UNDER 37 C.F.R. §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1756

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akifumi KAMIJIMA et al.

Group Art Unit: 1756

Application No.: 09/966,080

Examiner: J. Ruggles

Filed: October 1, 2001

Docket No.: 110735

For: A METHOD FOR FABRICATING A RESIST PATTERN, A METHOD FOR
PATTERNING A THIN FILM AND A METHOD FOR MANUFACTURING A
MICRO DEVICE

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the September 16, 2003, Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.

12/16/2003 SDENB0B1 00000087 09966080

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